


<b>Search Notes</b>  	<b>Application/Control No.</b>  10824337	<b>Applicant(s)/Patent Under Reexamination</b>  SATO, TATSUHIRO
	<b>Examiner</b>  Nguyen, Phu H	<b>Art Unit</b>  1731

### SEARCHED

Class	Subclass	Date	Examiner
65	31	11/14/06	P.N

### SEARCH NOTES

Search Notes	Date	Examiner
quartz adj glass adj jig.clm. and etching	12/05/2006	P.N
quartz adj glass and (fire abrasion) and annealing and etching	11/16/2006	P.N
(vapor gas) adj phase adj (etching purif\$8) amd 65/\$.ccls.	12/05/2006	P.N
see East Search History	6/8/2007	P.N
see updated East Search History	11/1/2007	P.N
see updated East Search history	7/21/2008	P.N

### INTERFERENCE SEARCH

Class	Subclass	Date	Examiner